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Atty. Dkt. No. 016891-0857

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Mitsuasa TAKAHASHI  
Title: METHOD FOR  
MANUFACTURING THIN FILM  
TRANSISTOR  
Appl. No.: 10/617,170  
Filing Date: 07/11/2003  
Examiner: I.U. Anya  
Art Unit: 2825

**AMENDMENT AND REPLY UNDER 37 CFR 1.116**

Mail Stop AMENDMENT  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated August 24, 2004, concerning the above-referenced patent application.

Please amend the application as follows:

OK To Enter 12/15/04 Anya